



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Spd Jay  
6/28/00

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In re application of : Confirmation No. 3756  
Tomohiro OKUMURA et al. : Attorney Docket No. 00177/530809  
Serial No. 09/511,398 : Group Art Unit 1762  
Filed February 23, 2000 : Examiner M. Padgett

**PLASMA PROCESSING  
METHOD AND APPARATUS**

**AMENDMENT**

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEE FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975.

Assistant Commissioner for Patents,  
Washington, D.C.

Sir:

Responsive to the Office Action of December 19, 2001, a three month extension of time being filed concurrently herewith, please amend the above-identified application as follows.

**In the Specification and Abstract:**

Kindly replace the original specification and abstract with the enclosed substitute specification and abstract.

**In the Claims:**

Kindly cancel claim 1 presently pending in the application without prejudice.